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## BIB DATA SHEET

CONFIRMATION NO. 6791

<b>SERIAL NUMBER</b> 10/517,765	<b>FILING or 371(c) DATE</b> 02/03/2006 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> 040509		
<b>APPLICANTS</b> Takashi Ozaki, Nakano-ku, JAPAN; Kenichi Suzaki, Nakono-ku, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/08097 06/26/2003 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-187566 06/27/2002 JAPAN 2003-084774 03/26/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 09/14/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 12	<b>TOTAL CLAIMS</b> 18	<b>INDEPENDENT CLAIMS</b> 6
Verified and Acknowledged	/SONYA D MCCALL SHEPARD/ Examiner's Signature		Initials			
<b>ADDRESS</b> KRATZ, QUINTOS & HANSON, LLP 1420 K Street, N.W. Suite 400 WASHINGTON, DC 20005 UNITED STATES						
<b>TITLE</b> Substrate treating apparatus and method for manufacturing semiconductor device						
<b>FILING FEE RECEIVED</b> 1630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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